

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Group 1795

Steven A. Soper *et al.*

Examiner Lee, Sin J.

Serial No. 10/734,816

Confirmation No. 3513

Filing Date: December 12, 2003

For: Photoresist-Free Micropatterning on Polymer Surfaces (File Soper 0023.1)

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the July 14, 2008 Office Action, please amend the Claims as shown in the Appendix.

A fee of \$555 is being paid online via EFS-Web to extend the time for response by three months, from October 14, 2008 to January 14, 2009; calculated for a small entity.

If this amount is incorrect, please refer to the Deposit Account Authorization previously filed with this application. If any additional extension of time is required, please consider this paper a petition for the total extension of time required.